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LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT

ATTY. DOCKET NO.: P69995US0 GROUP ART UNIT: Not Yet Assigned
SERIAL NO.: New Application FILING DATE: August 3, 2004
APPLICANT(S): Yong Hae KIM, et al. TODAY'S DATE: August 3, 2004

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	INT'L CLASS	SUB- CLASS	FILING DATE (If Appropriate)
DG	AA <u>6,166,399</u>	<u>12/26/00</u>	<u>Zhang, et al.</u>	<u>H01L</u>	<u>29/04</u>	<u>6/19/99</u>
	AB					

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	SUB- CLASS	TRANSLATION (YES) (NO)
DG AC <u>2002-50766</u>	<u>2/15/02</u>	<u>JAPAN</u>	<u>H01L</u> <u>29/786</u>	<u>X</u> <u>1</u>
AD				

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

DG AE	<u>Isao Hasegawa, et al.; "A Novel Crystallization Method for Silicon Films with a Near-infrared Laser and Absorption Layer - Zone Melting for Films -"; TFT2-1; AM-LCD' 03; pp. 25-28.</u>
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EXAMINER	DATE CONSIDERED
/David E. Graybill/	<u>01/04/2007</u>

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).